

03500.015262



1762

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAKESHI SHISHIDO ET AL.) : Examiner: M. Padgett
Application No.: 09/822,191) : Group Art Unit: 1762
Filed: April 2, 2001) :
For: EXHAUST PROCESSING METHOD,)
PLASMA PROCESSING METHOD :
AND PLASMA PROCESSING)
APPARATUS : September 29, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

(a) Introductory Comments

In response to the Office Action dated June 29, 2006, kindly amend the subject application as follows.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

September 29, 2006

(Date of Deposit)

Peter Saxon

(Name of Attorney for Applicant)

Signature

September 29, 2006

Date of Signature